





Silicon-Germanium Nanotechnology For Wireless Communications and Radars



THE ELISHA YEGAL BAR-NESS CENTER FOR WIRELESS COMMUNICATIONS AND SIGNAL PROCESSING RESEARCH

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Motivation: Cost-Efficient, Highly Integrated RF Systems-on-a Chip

Two Solutions:

1. SiGe heterojunction bipolar transistors (HBTs): Mature technology

2. SiGe nanowire heterojunctions: New approach

Traditional RF Devices

1. High-speed transistors (frequency and power/gain): integration versus Dielectric Copper individual device Tungsten SIGe performance N Collector Ceep Trenc (0.5 - 200 GHz)N⁺ Subcollector

2. <u>Gunn diodes</u>: so far, exclusively III-Vs

P Substrate

Traditional RF Devices: SiGe HBTs

Si, E_G =1.1 eV (T=300K) Ge, E_G =0.66 eV (T=300K)



Energy band diagrams for Si and Ge

Traditional RF Devices: SiGe HBTs



Si_xGe_{1-x} alloys: Energy gap versus composition

Traditional RF Devices: SiGe HBTs



Schematic of a SiGe HBT with a composition modulated base: drift versus diffusion

Traditional RF Devices



SiGe RF versus CMOS and III-Vs: same performance for lower cost



An array of radiating antenna elements transmitting and receiving active components at each element (T/R modules); enables digital beam forming using monolithic microwave integrated circuits (MMIC)



Phase Array Radars (PARs) are known since 1990 but were too costly to produce and operate [°]9



New generation of Phase Array Radars based on SiGe MMIC



Collision Avoidance Automotive Radars (CAARs): Standard within the next 5 years

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Brief Introduction to Gunn Effect GaAs, InP, etc.



Inter valley electron transfer creates RF oscillations

Si/Ge Heterojunction: Electron Momentum Mismatch - Similar to Gunn Effect



Electron transfer creates RF oscillations?

Materials Science: Si/Ge Lattice Mismatch

Si



Si and Ge are semiconductors with the lattice mismatch of 4.2 % (strain and defect formation)

Si/Ge Nanowire Heterojunction: Strain Relaxation via Lateral Expansion



Strain relaxation in nanowires: C.-Y. Wen, Science 2009.

Si/Ge Nanowire (NW) Growth: Structural Properties



Straight, nearly constant diameter Si/Ge NWs with smooth surfaces and lateral expansion near the NW heterojunction (Tsybeskov's group, APL 2010, 20012, 2014)

Si/Ge Nanowire VLS Growth: Microstructure and Optical Properties



Zooming in: ... nearly constant diameter Si/Ge NWs with ... lateral expansion near the NW heterojunction $(ECS \ 2014)$

Si/Ge Nanowire Close to Center: HR TEM Image and FFT (Nearly Perfect)



Brief Summary of Si/Ge Nanowire Heterojunction Electrical Properties

- Disrupted flow of carriers
- Current oscillations at GHz frequencies
- Negative photoconductivity
- Other features related to the proposed conductivity mechanism
- <u>Natural integration with CMOS</u> <u>low cost/high performance MMICs</u>

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Ge

Si